(FILE 'HOME' ENTERED AT 15:02:51 ON 22 NOV 2006)

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       FILE 'USPATFULL' ENTERED AT 15:03:04 ON 22 NOV 2006
L1      640473 S ?POLISH? OR CHEMIMEC? OR PLANRAIZ? OR LAP? OR GRIND? OR ABRAD
L2      417385 S SILICA OR SIO2 OR SI2O3 OR SILICON(W)(DIOXIDE OR MONOXIDE)
L3      563762 S CA OR CALCIUM OR BA OR BARIUM OR SR OR STRONTIUM
L4        4174 S L1(P)L2(P)L3
L5       19739 S L2(5A)FUM?
L6         180 S L4(P)L5
L7           3 S L6(P)PH
L8         177 S L6   NOT L7
L9          16 S L8 AND (?POLISH? OR CHEMIMEC? OR PLANRAIZ? OR LAP? OR GRIND?
L10        161 S L8 NOT L9
               SET HIGH OFF
L11         21 S L10 AND (SEMICONDUCT? OR WAFER? OR CHIP#)
               SET HIGH ON
L12         21 S L10 AND L11
L13        416 S L4(P)PH
               SET HIGH OFF
L14        105 S L13 AND (SEMICONDUCT? OR WAFER? OR CHIP#)
               SET HIGH ON
L15        105 S L13 AND L14
L16        103 S L15 NOT (L7 OR L9 OR L12)
L17        128 S L13(P)(OXID? OR PEROXIDE OR H2O2)
L18         36 S L16 AND L17
L19         67 S L16 NOT L18
L20     101238 S (?POLISH? OR CHEMIMEC? OR PLANRAIZ? OR LAP? OR GRIND? OR ABRA
L21      70790 S (SILICA OR SIO2 OR SI2O3 OR SILICON(W)(DIOXIDE OR MONOXIDE))/
L22      98347 S (CA OR CALCIUM OR BA OR BARIUM OR SR OR STRONTIUM)/CLM
L23       1325 S L20 AND L21 AND L22
L24         96 S L23 AND FUMED/CLM
               SET HIGH OFF
L25         24 S L24 AND (SEMICONDUCT? OR WAFER? OR CHIP#)
               SET HIGH ON
L26         24 S L24 AND L25
L27         15 S L26 NOT (L7 OR L9 OR L12 OR L17)
L28          9 S L26 NOT L27
L29       1331 S L20 AND (L21 OR FUMED/CLM) AND L22
L30        282 S L29 AND PH/CLM
L31        234 S L30 NOT (L7 OR L9 OR L12 OR L17 OR L26)
               SET HIGH OFF
L32         43 S L31 AND (SEMICONDUCT? OR WAFER? OR CHIP#)
               SET HIGH ON
L33         43 S L31 AND L32
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